MOOV

Machine	KLA-Tencor Sufscan 6420
[illegible]	[illegible]
Electric source	208V/1Ph/16A
Wafer Size	6"
Features	Non-patterned wafer film surface analyzer. One automatic wafer handler. Defect map and histogram with zoom. 2D signal integration. Non-contaminating robotic handler. X-Y Coordinates Software. Random access sender/receiver unit.
Dimension:	Main Equipment:95*75*167CM Working table:45*73*90CM